



IFW

Docket No.: M1071.1917
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Toshihiro Okamatsu et al.

Application No.: 10/506,858

Confirmation No.: 4699

Filed: September 2, 2004

Art Unit: N/A

For: DIELECTRIC CERAMIC,
MANUFACTURING METHOD
THEREFOR, AND MULTILAYER
CERAMIC CAPACITOR

Examiner: Not Yet Assigned

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: March 8, 2006

Respectfully submitted,

By Edward A. Meilman

Edward A. Meilman

Registration No.: 24,735

DICKSTEIN SHAPIRO MORIN &
OSHINSKY LLP

1177 Avenue of the Americas
41st Floor

New York, New York 10036-2714
(212) 835-1400

Attorney for Applicant